

Title (en)

LASER ABLATION OF WAVEGUIDE STRUCTURES

Title (de)

LASERABLATION VON WELLENLEITERSTRUKTUREN

Title (fr)

ABLATION PAR LASER DE STRUCTURES GUIDE D'ONDE

Publication

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Application

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Abstract (en)

[origin: WO0048024A1] A method of processing an optical device incorporating a waveguide, the method comprising the step of utilizing a laser to heat a surface of the device to alter an optical characteristic of the waveguide, wherein the power density of the laser is selected to effect ablation.

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